



Ressources - Équipements	Taux (\$/h)		
	Académique	Académique Externe 15% FIR*	Non Académique 50% FIR*
Ball Mill	20	23	60
Chemisorption	10	12	30
Diamond Saw	10	12	30
Differential Scanning Calorimeter (DSC)	5	6	15
Electron Microscope (Desktop SEM-EDS)	30	35	90
Electron Microscope (SEM-FEG-EDS)	60	69	180
Elemental Analyzer (C/H/N/O)	60	69	180
Elemental Analyzer (C/S)	30	35	90
Epoxy Mounting Station	30	35	90
Fluxer	40	46	120
Ion Sputter Coater Au/Pd	30	35	90
Ion Sputter Coater Pt/C	30	35	90
Laser Flash Analyzer (LFA)	5	6	15
Laser Granulometer	40	46	120
Mass Spectrometer (MS)	5	6	15
Muffle Furnace	3	3,5	5
Photomicroscope	15	17	45
Physisorption (BET)	5	6	15
Polishing Station	60	69	180
Stereomicroscope	15	17	45
Thermogravimetric Analyzer (TGA)	5	6	15
X-Ray Data Computer Station	30	35	90
X-Ray Diffraction In Situ Chamber	30	35	90
X-Ray Diffractometer (XRD)	30	35	90
X-Ray Fluorescence Spectrometer (XRF)	40	46	120
X-Ray Microtomograph (Micro-CT)	30	35	90
X-Ray Photoelectron Spectrometer (XPS)	60	69	240
<b>Ressources - Professionnels</b>			
PRAM - Consulting	66	76	130
PRAM - Service	66	76	130
PRAM - Training	66	76	130

\* Le taux inclus les frais indirects de recherche (FIR), taux arrondi.